



Inventor: Adam Cohen et al.  
 For: MICROFLOW BASED  
 DIFFERENTIAL PRESSURE SENSOR  
 Appln. No.: 10/021,860  
 Filing Date: December 13, 2001  
 Atty. Docket: 364106/0286  
 Sheet No. 1 of 3

FORMAL DRAWINGS

STROOCK & STROOCK & LAVAN, LLP  
 180 Maiden Lane  
 New York, New York 10038  
 (212) 806-5400

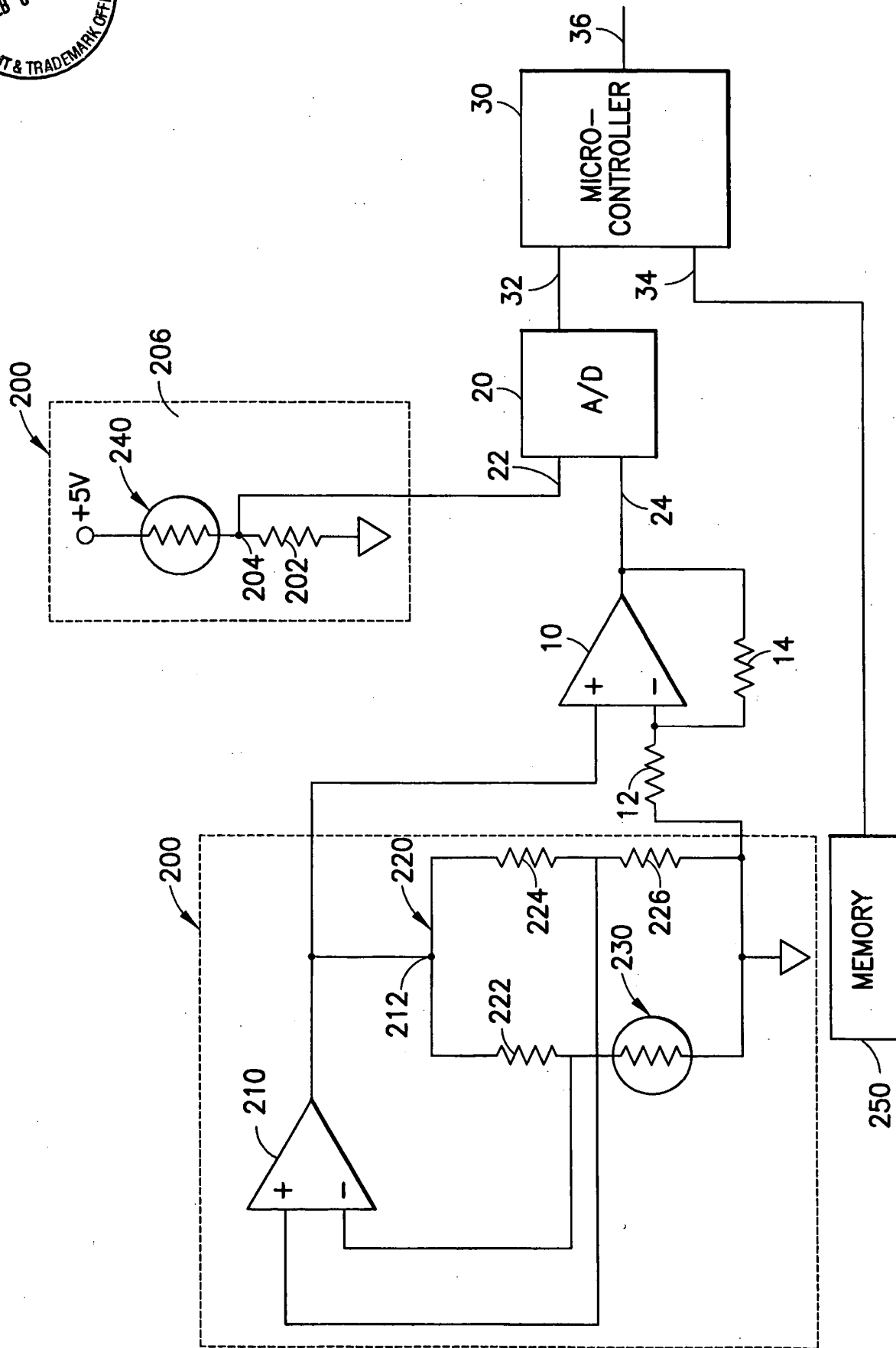
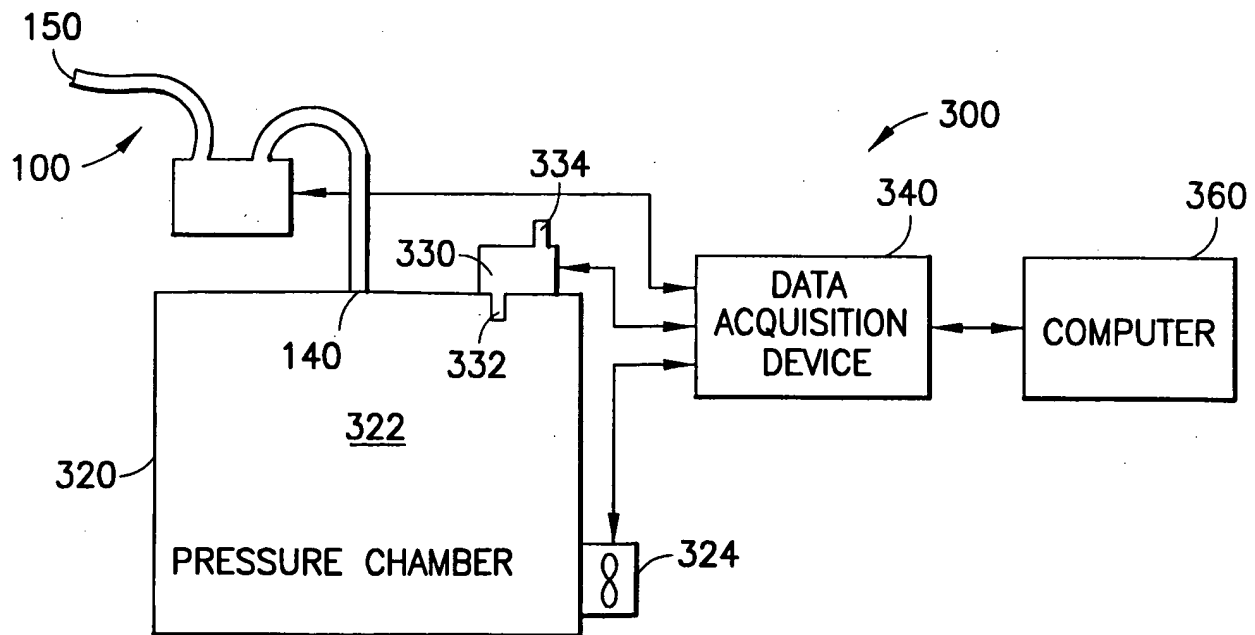
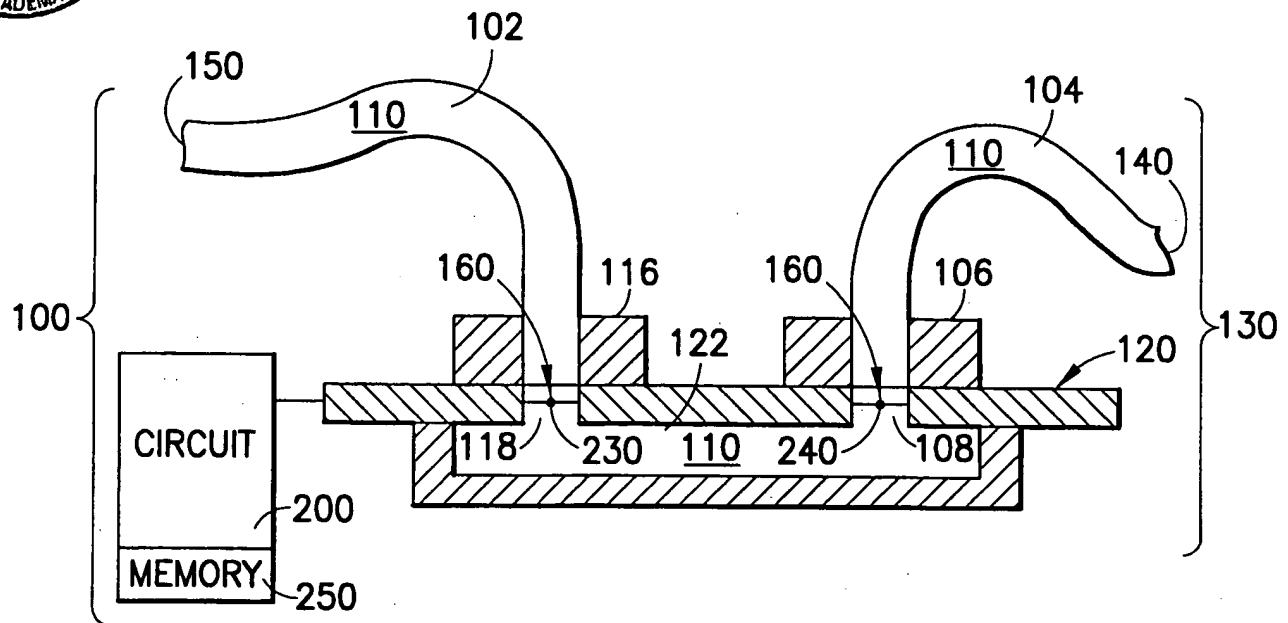
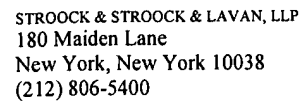


FIG. 1





Inventor: Adam Cohen et al.  
For: MICROFLOW BASED  
DIFFERENTIAL PRESSURE SENSOR  
Appl. No.: 10/021,860  
Filing Date: December 13, 2001  
Atty. Docket: 364106/0286  
Sheet No. 3 of 3

FORMAL DRAWINGS

STROOCK & STROOCK & LAVAN, LLP  
180 Maiden Lane  
New York, New York 10038  
(212) 806-5400

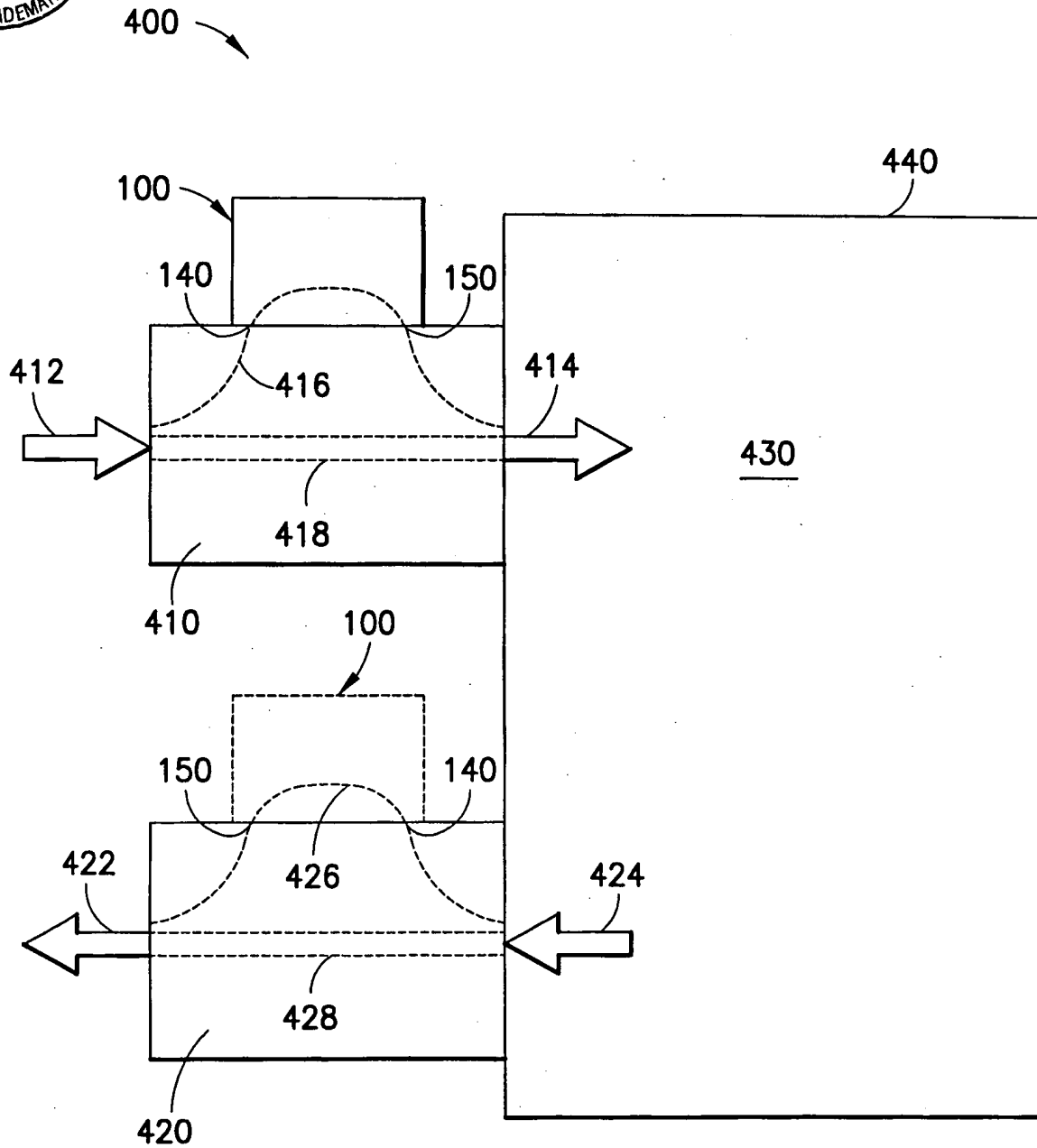


FIG. 4